

Form PTO-1449 (modified)

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102-0118US2Serial No.
09/740,751

List of Patents and Publications for Applicant's

Inventor/Applicant:

Tongbi Jiang et al. / Micron Technology, Inc.

INFORMATION DISCLOSURE STATEMENT

Title: Method for Forming Novel Zero Force
Insertion Sockets Using Negative Thermal
Expansion Materials (*as amended previously*)Filing Date:
12/19/00Group:
3729

(Use several sheets if necessary)

U.S. Patent Documents

| Exam. Init. | Ref. Des. | Document Number | Date | Name | Class | Sub Class | Filing Date of App. |
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| RC | A1 | 4,513,055 | Apr. 23, 1985 | Leibowitz | 428 | 245 | |
| | A2 | 6,274,932 | Aug. 14, 2001 | Mikagi | 257 | 754 | |
| | A3 | 6,187,700 | Feb. 13, 2001 | Merkel | 501 | 32 | |
| | A4 | 5,497,545 | Mar. 12, 1996 | Watanabe et al. | 29 | 830 | |
| | A5 | 5,919,720 | Jul. 6, 1999 | Sleight et al. | 501 | 126 | |
| | A6 | 5,641,291 | Jun. 24, 1997 | Sueki et al. | 439 | 83 | |
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| | A9 | 5,123,849 | Jun. 23, 1992 | Deak et al. | 439 | 66 | |
| | A10 | 5,387,121 | Feb. 7, 1995 | Kurz | 439 | 342 | |
| | A11 | 5,433,778 | Jul. 18, 1995 | Sleight | 106 | 40 | |
| | A12 | 5,514,360 | May 7, 1996 | Sleight et al. | 423 | 593 | |
| RC | A13 | 5,466,169 | Nov. 14, 1995 | Lai | 439 | 264 | |

Foreign Patent Documents

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Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

| Exam. Init. | Ref. Des. | Citation |
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| RC | C1 | T.A. Mary et al., "Negative Thermal Expansion from 0.3 to 1050 Kelvin in ZrW_2O_8 ," <i>Science</i> , Vol. 272, pp. 91-93 (Apr. 5 1996). |
| RC | C2 | Anonymous, "Seimens Demonstrates Fingertip Chip Sensor," <i>Semiconductor International</i> , pp. 33-34 (Apr. 1998). |

EXAMINER: /Rick Chang/

DATE CONSIDERED: 10/03/2006

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

INFORMATION DISCLOSURE STATEMENT — PTO-1449 (MODIFIED)